

PATENT
2114-0117PUS1

IN THE U. S. PATENT AND TRADEMARK OFFICE

Applicant: Takanori ICHIKI Conf: 5623
Serial No.: 11/590,969 Art Unit: 1759
Filed: January 5, 2007 Examiner: TAI, Xiuyu
For: MICRO PLASMA JET GENERATOR

REPLY UNDER 37 C.F.R.1.114

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Due May 3, 2011

Sir:

In response to the Office Action mailed February 03, 2011, and the Advisory Action dated April 20, 2011, the following remarks are respectfully submitted in connection with the above-identified application:

This Paper includes
Amendments to the Claims,
Remarks, and
Copy of "Review of Inductively Coupled Plasmas for Plasma Processing."

A Request for Continued Examination (RCE) is being filed concurrently.